

Image

PATENT APPLICATION 1753

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of
Kazunori ANAZAWA et al.

Application No.: 10/080,701

Filed: February 25, 2002

Docket No.: 112055

For: PRODUCING APPARATUS AND PRODUCING METHOD FOR MANUFACTURING
CARBON STRUCTURE

INFORMATION DISCLOSURE STATEMENT

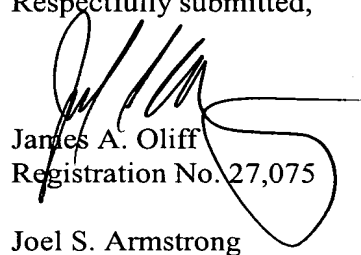
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. English-language Abstracts of the non-English language references are attached hereto. (Refs. 1-2)
- ☒ 3. A computer-generated English translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 1-3.

Respectfully submitted,


James A. Oliff
Registration No. 27,075

Joel S. Armstrong
Registration No. 36,430

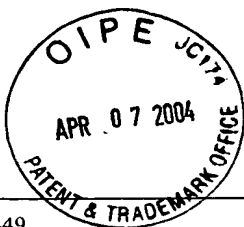
JAO:JSA/amo

Date: April 7, 2004

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 112055		APPLICATION NO. 10/080,701	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Kasunori ANAZAWA et al.			
				FILING DATE February 25, 2002			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	1	JP A 8-198611 w/ abst & trans	08/06/1996	Japan			
	2	JP A 9-309711 w/ abst & trans	12/02/1997	Japan			
	3	JP B1 3073986 w/ trans	06/02/2000	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	4	Yokomichi, Haruo et al. "Effects of High Magnetic Field on the Morphology of Carbon Nanotubes and Selective Synthesis Of Fullerenes." <i>Applied Physics Letters</i> , Vol. 74, No. 13; 29 March 1999					
EXAMINER				DATE CONSIDERED			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: April 7, 2004